

Specification

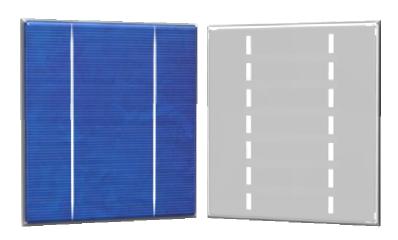
Technical Data sheet

 DMS loc.:
 Rev.:
 Doc.:
 Rev. date:
 Doc. owner:

 8100.03E
 03
 FO
 28-05-2013
 QA

Cell Type: H-pattern / segmented Back-side Configuration 08 Physical location:

Description



Cell Layout H_GEN_02

Dimensions		
Feature	ualification	Permitted Deviation
Outer dimensions	156mm x 156mm	± 0.5 mm
Cell thickness nominal as ordered	on wafer level	± 30 μm
Bow	Cell placed on flat surface sunny side up. Distance between centre of cell and flat surface	<= 2.5mm.

Front surface		
Width of busbar	1.8 mm	± 0.1 mm
Number of busbar	2	
Distance between the centre lines of	75.0	± 0.2 mm
busbar		
Material of busbar	Silver	

Back surface		
Width of busbar	4 mm	± 0.5 mm
Number of segments	8	
Length of segment interruption	6 mm	± 0.5 mm
Number of busbar	2	
Distance between the centre lines of	75.0	± 0.2 mm
busbar		
Material of busbar	Silver	
Material of the surrounding parts of the	Aluminum	
back surface of the cell		

Electrical properties		
Power	Power classes according to P max at standard test conditions (STC, AM 1.5, 1000 W/m², 25°C) Accuracy of measurement ± 1.5% relative to ISE certified reference cell	Divided in classes, see below
Reverse bias criteria	Reverse dark measurement V_{bias} = -12 V allowed current V_{bias} = -6 V allowed current measurement accuracy \pm 2%	I bias <2.0 A, I bias <0.4 A.
Shunt resistivity	(Dark I-V measurement) at 0V	R _{sh} > 15 Ohm

Typical data at STC (non encapsulated cells)*

Cellclass	Pmpp(W)	Efficiency(%)	Voc(mV)	Isc(A)
S156PS355	3.55	14.60	604	7.69
S156PS360	3.60	14.80	606	7.74
S156PS365	3.65	15.00	607	7.80
S156PS370	3.70	15.20	610	7.86
S156PS375	3.75	15.40	613	7.92
S156PS380	3.80	15.60	615	7.98
S156PS385	3.85	15.80	618	8.04
S156PS390	3.90	16.00	619	8.14
S156PS395	3.95	16.20	620	8.22
S156PS400	4.00	16.40	622	8.28
S156PS405	4.05	16.60	625	8.35
S156PS410	4.10	16.80	627	8.41
S156PS415	4.15	17.00	630	8.47
S156PS420	4.20	17.20	632	8.53